

L Number	Hits	Search Text	DB	Time stamp
1	3295	parabolic adj mirror	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 09:21
2	9102	concave adj mirror	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 08:50
3	648	(oscillator or laser) same (parabolic adj mirror)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 08:54
4	22	excimer and ((oscillator or laser) same (parabolic adj mirror))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 08:54
5	3162	convex adj mirror	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 08:53
6	604	(oscillator or laser) same (convex adj mirror)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 08:54
7	43	excimer and ((oscillator or laser) same (convex adj mirror))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 08:54
8	62	(excimer and ((oscillator or laser) same (parabolic adj mirror))) (excimer and ((oscillator or laser) same (convex adj mirror)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 08:55
9	2	("5,995,265").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 09:20
10	546	beam with homogenizer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 09:21
11	12	(parabolic adj mirror) and (beam with homogenizer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/26 09:21

Pat Family in STN

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Author(s): Helen, Y.; Dassow, R.; Mourgues, K.; Bonnaud, O.; Mohammed-Brahim, T.; Raoult, F.; Koehler, J.R.; Werner, J.H.; Lemoine, D.

Author Affiliation: Groupe de Microelectron. et Visualisation, Rennes I Univ., France

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